

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Branco et al.

Serial No.: 09/617,454

Filed: July 17, 2000

Title: Method for Cleaning Plasma Etch
Chamber Structures

Attorney Docket No.: CY-0015

Group Art Unit: 1746

Examiner: Markoff, A.

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RESPONSE TO OFFICE ACTION

- 5 Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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A. Introductory Comments

The following is submitted in response to the Office Action dated December 17, 2003,
and is currently due March 17, 2004.

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37 C.F.R. 51.8

I hereby certify that this correspondence is being

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☒ transmitted via facsimile to the United States Patent and Trademark Office to fax number: 1-703-872-9306Date of Transmittal: MARCH 16, 2004☐ deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents,
P.O. Box 1450, Alexandria, VA 22313-1450.

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Date of Deposit: _____

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Signature: Bradley T. Sako